

<b>Notice of References Cited</b>	Application/Control No. 10/716,421	Applicant(s)/Patent Under Reexamination JEON, HYOUNG-WOO	
	Examiner HELEN SHIBRU	Art Unit 2621	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0043784	11-2001	Shirata et al.	386/21
	B	US-			
	C	US-			
	D	US-			
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**FOREIGN PATENT DOCUMENTS**

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